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Laser manipulation of iron for nanofabrication

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We fabricate iron nanolines by depositing an atomic beam of iron through a far-off resonant laser standing wave (SW) onto a glass-ceramic substrate. The laser SW is tuned 200 MHz above the ${}^5D_4 \rightarrow {}^5F_5^o$ ${}^{56}\text{Fe}$ transition at a vacuum wavelength of 372.099 nm. The resulting nanolines exhibit a period of 186 nm, a height above the background of 8 nm and a full width at half maximum of 95 nm. These nanostructures cover a surface area of $\approx 1.6 \times 0.4 \text{ mm}^2$, corresponding to ≈ 8600 iron lines with a length of $\approx 400 \text{ }\mu\text{m}$. © 2004 American Institute of Physics. [DOI: 10.1063/1.1811804]

One of the most important topics of modern magnetism concerns the fabrication of periodic magnetic nanostructures. These structures constitute model systems for the study of magnetic interactions and switching behavior,¹ show phenomena-like magnetic photonic band gaps² and will be required for future magnetic data storage at ultrahigh areal densities. Despite the fundamental and technological interest, the fabrication of macroscopic, uniform arrays of well-defined, high-resolution magnetic nanostructures remains a challenge. It is in this spirit that nanofabrication via atom optics attracted our interest as it allows for an inherently parallel, ultrahigh vacuum compatible fabrication of nanostructures with unprecedented periodicity.^{3,4}

Nanofabrication via atom optics is based on the interaction between an atomic beam and a far-off resonant laser standing wave (SW). The atoms, when crossing the laser SW, experience a spatially varying optical potential that, in the first approximation, follows the SW intensity profile.⁵ When the laser frequency is tuned above (below) an atomic resonance, the atoms gather in the regions of low (high) light intensities. A substrate is then placed into the modulated atomic beam and nanostructures with a subwavelength period are grown. However, the structure width deteriorates fast with an increasing divergence of the atomic beam.⁶ Moreover, the SW optical potential is extremely shallow and so the atomic velocities along the SW direction must be low for the atoms to be “trapped” in SW nodes (antinodes). For these two reasons, a high degree of collimation of the atomic beam is required. In practice, laser cooling schemes are applied as they lead to extremely well-collimated atomic beams with no loss of flux.⁷ It is this laser cooling requirement that has limited nanofabrication via atom optics to just a few atomic species with a suitable optical transition. So far, laser-focused nanofabrication was demonstrated only with sodium,⁸ chromium,³ aluminum⁹ and ytterbium¹⁰ in the direct deposition regime, and with cesium¹¹ via lithography with a self-assembled monolayer as the resist. We note that all these atoms possess a closed (or almost closed) optical transition that allows for efficient laser collimation.⁷

In this letter we demonstrate atom-optical nanofabrication with iron. An iron atomic beam is deposited onto a glass-ceramic substrate through a one-dimensional laser SW tuned 200 MHz above the ${}^5D_4 \rightarrow {}^5F_5^o$ ${}^{56}\text{Fe}$ transition at a vacuum wavelength of 372.099 nm. The nanoscopically corrugated surface consists of highly uniform iron nanolines with a period of 186 nm, a full width at half maximum (FWHM) of 95 nm and a height (above the background) of 8 nm. About 8600 iron lines with a length of $\approx 400 \text{ }\mu\text{m}$ are grown in a single deposition run of 30 min. We mention here that a different approach to the fabrication of periodic iron nanowires was applied by Tulchinsky *et al.*,¹² who employed laser-focused chromium nanolines as a shadow mask for an iron evaporator. In contrast, our nonlithographic approach relies on direct deposition of laser-manipulated iron.

For laser manipulation, iron is a considerably more difficult element than any of the atoms used for atom-optical nanofabrication so far. Naturally occurring isotopes of iron are: ${}^{54}\text{Fe}$ (abundance 5.8%), ${}^{56}\text{Fe}$ (91.8%), ${}^{57}\text{Fe}$ (2.1%) and ${}^{58}\text{Fe}$ (0.3%). The dominant isotope ${}^{56}\text{Fe}$ has a nuclear spin $I=0$ and thus no hyperfine structure. The most suitable optical transition for laser collimation and SW focusing is the ${}^5D_4 \rightarrow {}^5F_5^o$ resonance with a transition wavelength of $\lambda = 372.099 \text{ nm}$, a natural linewidth $\Gamma/2\pi = 2.6 \text{ MHz}$ and a saturation intensity $I_S = 62 \text{ W/m}^2$. However, this is not a closed transition as considerable, dipole-allowed leaks exist from the upper state to the metastable states 5F_5 and 5F_4 . Repumping from these two states back into ${}^5F_5^o$ at 501.35 and 512.88 nm is an option to enhance the collimation efficiency.

For our experiment, the ultraviolet laser light was obtained by frequency doubling the output of a titanium-doped sapphire laser in an external enhancement doubling cavity based on a lithium triborate (LBO) crystal. This optical system for iron was built by upgrading the optics and replacing the LBO crystal in our earlier chromium setup (425 \rightarrow 372 nm).¹³ A thermal beam of iron atoms was produced from a high temperature effusion cell held at 2150 K. At these high temperatures iron becomes extremely corrosive and reactive. A beryllium oxide crucible filled with iron powder was used. The fraction of ${}^{56}\text{Fe}$ atoms that remain in the ground state 5D_4 at 2150 K is 46%. The other atoms are thermally excited into the other 5D levels. The vacuum pres-

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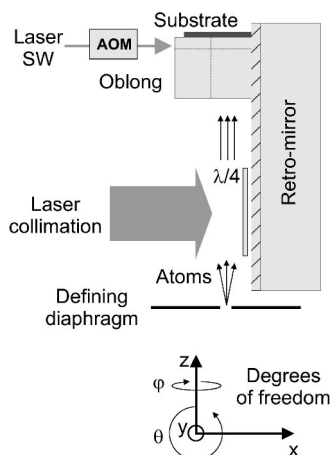


FIG. 1. *In vacuo* optics including the sample holder. The required degrees of freedom of the unit are also shown.

sure in the course of deposition was below 10^{-6} mbar. After the iron beam passed a defining diaphragm of 1.5×1.5 mm², it entered the deposition chamber.

In the deposition chamber an *in vacuo* optical unit is mounted. It is schematically shown in Fig. 1. The required degrees of freedom of the unit are three translations along x , y and z , and two rotations around y and z , respectively. The mirror is a zerodur substrate coated with enhanced aluminum. A glass oblong serves as the sample holder. This oblong was cut from a prism with the right angle specified to within ± 0.015 mrad. The high quality optical faces of the oblong are used as the reference for the angular adjustment of the sample with respect to the mirror. The sample rests on the top face of the oblong. The atom beam is along z and the laser SW along x . Two grooves—one for the atoms and the other one for the laser SW—were cut into the oblong. A quarter-wave ($\lambda/4$) plate is located in front of the mirror at the position where laser collimation takes place. Using this $\lambda/4$ plate a polarization gradient scheme of laser cooling can be created. The optical parts of the *in vacuo* unit are mounted into a holder made of high-strength aluminum that is in turn mounted onto a vacuum manipulator. This manipulator provides all degrees of freedom required to align the experiment.

The laser is stabilized at a frequency near the $^5D_4 \rightarrow ^5F_5$ ^{56}Fe transition for which laser collimation is optimized. In our iron experiment, the detuning from the resonance was determined to $(-2 \pm 0.5)\Gamma$. The frequency stabilization scheme is based on the detection of a laser-induced fluorescence (LIF) signal from the iron beam crossing a probe laser. The fluorescence from the intersection is then imaged onto a split photodiode that provides a dispersion signal for the locking electronics.⁶ The collimation angle of the laser-cooled iron beam was optimized empirically. We found out that the best results were obtained with no polarization gradients and no magnetic fields applied. The laser beam used for cooling contained a power of 24 mW and its $1/e^2$ intensity full widths were 20 mm along z and 3 mm along y . The fraction of the atomic beam we were able to detect by LIF after cooling exhibited a FWHM collimation angle $\alpha = 0.95 \pm 0.10$ mrad. We note here that these “detectable” atoms are those ones that then couple to the SW laser field. No repumping scheme back to 5F_5 was applied.

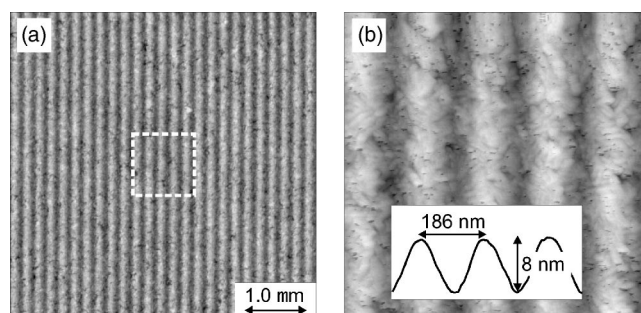


FIG. 2. Laser-focused nanolines of iron. AFM scans: (a) $5 \times 5 \mu\text{m}^2$, (b) $1 \times 1 \mu\text{m}^2$. (b) Corresponds to the surface area encapsulated in the white square in (a). Inset in (b): Structure profile averaged over $1 \mu\text{m}$ along the lines.

The SW laser beam was tuned ≈ 200 MHz above the involved iron resonance by an acousto-optic modulator. The SW contained a laser power of 84 mW and was focused down to $1/e^2$ intensity full widths of $\approx 200 \mu\text{m}$ along y and $\approx 80 \mu\text{m}$ along z . At this SW optical intensity, the effect of the SW on the atoms was clearly visible by LIF imaging of the iron beam following a free propagation distance of ≈ 700 mm from the SW. The *in vacuo* optical unit is moved into the iron beam such that the atoms can pass through the vertical groove in the sample holder (Fig. 1). A glass-ceramic substrate was used with a root-mean-square surface roughness of $< 5 \text{ \AA}$. While the deposition was in progress, the SW was cut by the substrate surface at its center. The deposition time was 30 min.

The fabricated sample was subsequently investigated by means of atomic force microscopy (AFM) *ex vacuo*. A $5 \times 5 \mu\text{m}^2$ AFM scan taken at the center of the iron patch is shown in Fig. 2(a). A highly uniform array of iron nanolines with a period of $\lambda/2 \approx 186$ nm is apparent. In Fig. 2(b) a $1 \times 1 \mu\text{m}^2$ AFM scan of the surface area encapsulated in the white square in Fig. 2(a) is presented. The structure profile averaged over $1 \mu\text{m}$ along the lines is shown in the inset of Fig. 2(b). The average structure FWHM and height (above the background) evaluate to ≈ 95 and 8 nm, respectively. Neither the images nor the line profiles were corrected for the AFM tip effects as their contribution to the measured structure broadening is estimated to be negligible, akin to earlier studies of laser-focused chromium nanolines by Anderson *et al.*⁶ In addition, the thickness of the background layer was measured to be 25 ± 5 nm using an ellipsometer. This implies a height-to-background ratio of $\approx 1:3$.

At this point it is interesting to compare the fabricated nanostructures with the iron flux distribution expected from theoretical considerations. To this end, we calculated the atomic trajectories in a laser SW. The Newton equation of motion with a force due to the SW optical potential was integrated for 10^6 random iron atoms with initial conditions corresponding to the Maxwell–Boltzmann statistics of a thermal (2150 K) iron beam that is collimated in the transverse direction to 0.95 mrad. The laser SW parameters were also set equal to those of the experiment. We estimate that only about 11% of atoms from the iron beam are affected by the SW.¹⁴ The final flux distribution at the substrate surface then exhibits an FWHM of 30 nm and a height-to-background ratio of 1:3. The discrepancy between the measured and modeled structure widths can most likely be attributed to surface growth effects.⁶ In addition to iron-on-substrate and

iron-on-iron growth, the presence of different contaminants during the deposition and subsequent investigation of the sample *ex vacuo* could also have contributed to a considerable structure broadening.

We also performed magnetic measurements on the fabricated sample. However, taking into account the large background layer, no signature of individual iron nanolines was expected. Indeed, both magnetic force microscopy and magneto-optical Kerr measurements revealed a ferromagnetic behavior with in-plane easy axis that was independent from the position on the iron patch (irrespective of the presence of nanolines). The drawback of the background layer could be overcome by nanofabrication of magnetic materials with periodically varying composition and thus magnetic properties. This can be achieved by selective manipulation of iron during simultaneous deposition of a number of other species. At this moment, we are performing a study that will allow us to engineer a material with periodically modulated magnetization that might be of interest for applications in magnetic data storage.

In conclusion, we have demonstrated nanofabrication via atom optics with iron. The iron nanostructures exhibited a period of 186 nm, a height above the background of 8 nm and a FWHM of 95 nm as determined with an AFM. The thickness of the background layer was estimated to about 25 nm. Considerably narrower structures with a smaller background are feasible from both atom-optical and surface growth perspectives. Repumping from the metastable states 5F back into the upper atomic level $^5F_5^o$ would certainly help to achieve better collimation angles and higher populations in the ground state 5D_4 . Then, atom optics would work better and considerably narrower nanostructures could be grown. In addition, experiments carried out in a clean UHV environment would allow for a better control of the surface growth processes with a possibly positive impact on the ultimate abilities of the technique. Probably the most limiting factor of all is the thermal population of the 5D states, other than the ground state 5D_4 , at oven temperatures that are required for a reasonably fast experiment. In order to solve this problem a considerable investment into the laser infrastructures would be required that can only hardly be justified at the present stage of development of nanofabrication via atom optics.

We note here that, independently from us, the group of Professor K.A.H. van Leeuwen from the Eindhoven University of Technology recently succeeded in fabricating iron nanolines via atom optics.¹⁵

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- ¹⁴About 46% of ^{56}Fe atoms remain in the ground state 5D_4 at an oven temperature of 2150 K. Since the probability for the atoms to decay to the metastable states 5F is 1:243 for every scattered photon, only $\approx 12\%$ of ^{56}Fe atoms leave the laser cooling region in the ground state, provided a completely saturated transition [E. te Sligte *et al.*, *Microelectron. Eng.* **67,68**, 664 (2003)]. In addition, there are 8.2% of other iron isotopes that do not couple to the SW laser field. This implies that only $\approx 11\%$ of all atoms are affected by the SW.
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